



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 4723

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/595,686	12/27/2006	250	4181	1751-405		
RULE						
APPLICANTS Jin Ho Choy, Seoul, KOREA, REPUBLIC OF; Eue Soon Jang, Seoul, KOREA, REPUBLIC OF; Jung Hee Won, Seoul, KOREA, REPUBLIC OF; ** CONTINUING DATA ***** This application is a 371 of PCT/KR04/02866 11/06/2004 ** FOREIGN APPLICATIONS ***** REPUBLIC OF KOREA 10-2003-0078244 11/06/2003 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED *** SMALL ENTITY ** 06/17/2007						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/REBECCA Y LEE/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWINGS 18	TOTAL CLAIMS 7	INDEPENDENT CLAIMS 2
ADDRESS ROTHWELL, FIGG, ERNST & MANBECK, P.C. 1425 K STREET, N.W. SUITE 800 WASHINGTON, DC 20005 UNITED STATES						
TITLE Method for Forming ZnO Nano-Array and ZnO Nanowall for Uv Laser On Silicon Substrate						
FILING FEE RECEIVED 515	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		